

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	10718320			
<b>Filing Date:</b>	19-Nov-2003			
<b>Title of Invention:</b>	DYNAMICALLY CONTROLLABLE REDUCTION OF VERTICAL CONTACT DIAMETER THROUGH ADJUSTMENT OF ETCH MASK STACK FOR DIELECTRIC ETCH			
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<b>Filer:</b>	Gideon Gimlan/Pam Disney			
<b>Attorney Docket Number:</b>	M-15208 US			
Filed as Large Entity				
<b>Utility Filing Fees</b>				
<b>Description</b>	<b>Fee Code</b>	<b>Quantity</b>	<b>Amount</b>	<b>Sub-Total in USD(\$)</b>
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1440	1440
Publication fee for republication	1505	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				1740